

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Confirmation No.: 1005

Applicants : Yasuo KOBAYASHI, et al.
U.S. Serial No. : 10/568,461
Filed : February 15, 2006
Examiner : Reema PATEL
Group Art Unit : 2812
For : SEMICONDUCTOR DEVICE, METHOD FOR
MANUFACTURING SEMICONDUCTOR DEVICE
AND GAS FOR PLASMA CVD

AMENDMENT ACCOMPANYING A REQUEST FOR CONTINUED PROSECUTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Mail Stop: AF

Sir:

In response to the FINAL Office Action mailed on October 6, 2008, please amend the above-identified application as set forth below and consider the following remarks.

This Amendment is accompanied by a Petition for Extension of Time (Three Months) to extend the due date for response to April 6, 2009, and a Request for Continued Examination (RCE). Payment for the extension fee (\$1,110) and the RCE (\$810) are paid by credit card.

Amendment to the claims begin on page 2.

Remarks begin on page 4.